

INFORMATION DISCLOSURE STATEMENT

Applicant : Ando et al.
App. No : 10/572,709
Filed : March 17, 2006
For : POSITIVE RESIST COMPOSITION
AND RESIST LAMINATE FOR LOW-
ACCELERATION ELECTRON BEAM
AND METHOD OF PATTERN
FORMATION
Examiner : Richard L. Schilling
Art Unit : 1795

CERTIFICATE OF EFS WEB
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I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

April 23, 2008

(Date)

Neil S. Bartfield, Ph.D., Reg. No. 39,901

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 5 (five) references to be considered by the Examiner. Also enclosed are 2 (two) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 4/23/08

By: Neil S. Bartfield

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